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Patent  
10980322-5

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Jian Bai et al.

Serial No.: 10/806,907

Filed: March 22, 2004

For: Ambient Pressure Matrix-Assisted Laser  
Desorption Ionization (MALDI) Apparatus and  
Method of Analysis

)  
) Examiner: Not Yet Assigned

)  
) Group Art Unit: 2881

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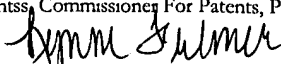
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Dated: June 14, 2004

  
Lynne Fulmer

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12089-4004 K2M

Respectfully submitted,

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Dated: June 14, 2004

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